



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Dapeng Wang

Serial No.: 10/729,112

Filed: December 5, 2003

For: DEFORMABLE PAD FOR
CHEMICAL MECHANICAL POLISHING

Confirmation No.: 3169

Examiner: R. Rose

Group Art Unit: 3723

Attorney Docket No.: 2269-3579.2US
(98-0062.02/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 22, 2005
Date

Signature

Shawnee MacDonald
Name (Type/Print)

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed May 23, 2005, the three-month shortened statutory period for response to which expires on August 23, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.